

RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE EXAMINING GROUP 2800**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Haupt

Docket No.:

2003 P 51718 US

Serial No:

10/766,053

Art Unit:

2822

Date Filed:

January 28, 2004

Examiner:

Thanh Y. Tran

usa L. O'Conroe

Title:

Method for N+ Doping of Amorphous Silicon and Polysilicon Electrodes in

Deep Trenches

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- Certification of Facsimile Transmission (1 page)
- Response under 37 C.F.R. § 1.116 (10 pages)

Respectfully submitted,

Theresa L. O'Connor Legal Assistant

Confirmation Respectfully Requested

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in Deep Trenches

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicant respectfully submits the following amendments and remarks in response to Examiner's Office Action dated March 21, 2007, which Action is made final. Applicant respectfully requests that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116 in order to place this application in a condition for allowance or alternatively to place the claims in better condition for an appeal, and respectfully request reconsideration of claims 1-27.